FIG. 1A

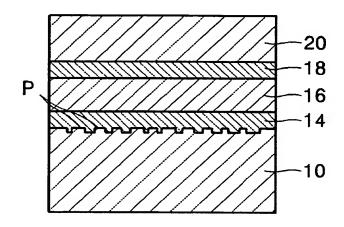


FIG. 1B

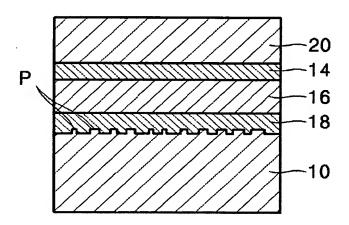


FIG. 2

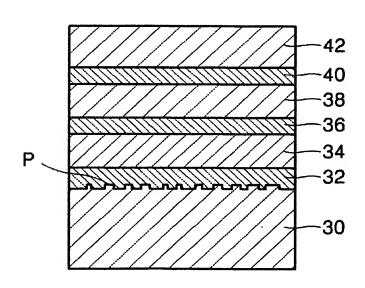


FIG. 3A

SUBSTRATE (1.1mm)

Ge-Sb-Te (33nm)

ZnS-SiO₂ (25nm)

PtOx (3.5nm)

ZnS-SiO₂ (50nm)

FIG. 3B

SUBSTRATE (1.1mm)

ZnS-SiO₂ (25nm)

Ge-Sb-Te (33nm)

ZnS-SiO₂ (25nm)

PtOx (3.5nm)

ZnS-SiO₂ (50nm)

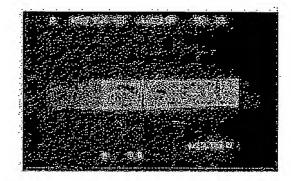


FIG. 4B

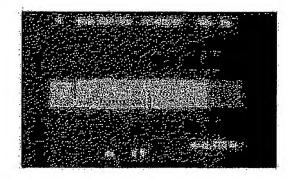


FIG. 4C



FIG. 4D

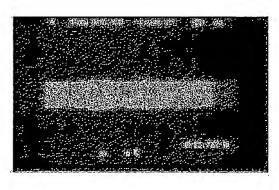
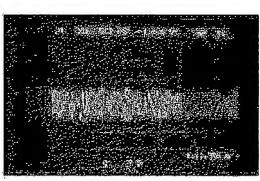


FIG. 4E



BEST AVAILABLE COPY

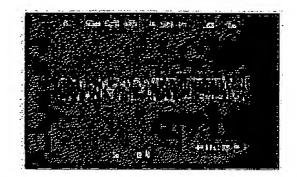


FIG. 5B

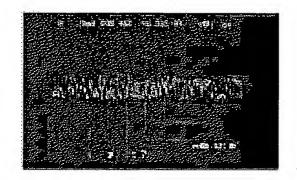


FIG. 5C

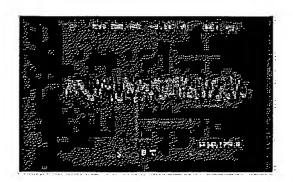


FIG. 5D

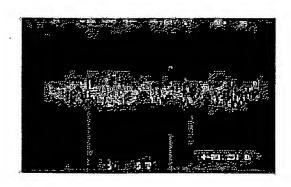


FIG. 5E



BEST AVAILABLE COPY

FIG. 6

